



Attorney Docket # 4797-9

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1754/11
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Manfred SCHINGNITZ et al.

Serial No.: 09/736,553

Filed: December 13, 2000

For: Process For The Utilization Of Halogen
Containing Remainders And Waste Materials

Examiner: Nguyen, Ngoc Yen
Group Art: 1754

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1450, Alexandria, VA 22313-1450, on

January 30, 2004
(Date of Deposit)

Thomas C. Pontani

Name of applicant, assignee or Registered Representative.

Signature

January 30, 2004
Date of Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

SIR:

Applicants hereby request a one-month extension of the original shortened statutory response period set in the Office Action of October 2, 2003. A check in the amount of \$110 in payment of the government fee for a one-month extension of time is enclosed herewith. Any additional fees or charges required at this time in connection with the present application may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

In response to the Office Action dated October 2, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 7 of this paper.

02/06/2004 RMEBRAHT 00000109 09736553

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